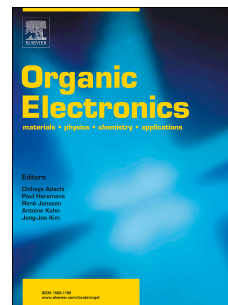


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Patterning organic transistors by dry-etching: The double layer lithography

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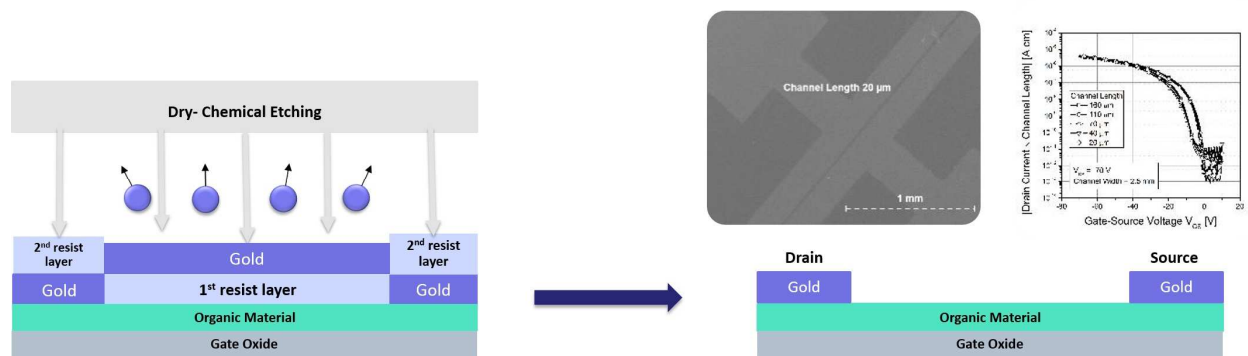
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